



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

May 18, 2026	
IGI Report Number	LG799653382
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND MIXED CUT
Measurements	9.66 - 9.68 X 6.11 MM

GRADING RESULTS

Carat Weight	4.01 CARATS
Color Grade	D
Clarity Grade	VS 1

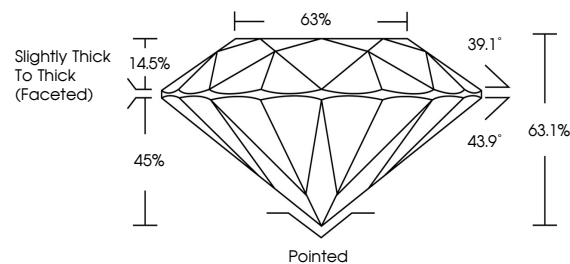
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	15 LG799653382

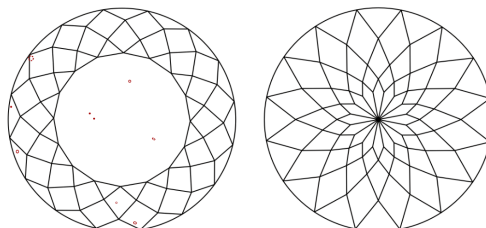
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG799653382
Report verification at lgi.org

PROPORTIONS

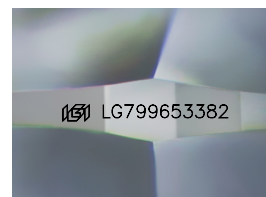


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

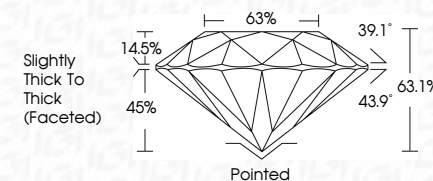
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www.igi.org

May 18, 2024	Q1 Report No LG79653392	4.01 CARATS
ROUND MIXED CUT		D
5.65 - 5.68 X 4.11 MM		VS 1
		63.1%
		63%
		Slightly Thick to Thick (Faceted)
		Pointed
		EXCELLENT
		EXCELLENT
		NONE
		631 LG79653392

Comments: Very Good Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIA